## 03000MR409122302

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C	APJ ABDUL KALAM TECHNOLOGICAL UNIVER	SIT	ΓŸ	(28)	KS		· ·
	Seventh Semester B.Tech Degree (S, FE) Examination May 2024	20	15	Scheme)		17	1
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## Course Code: MR409

## Course Name: Micro Electro Mechanical Systems

Max	. Ma	Duration	: 3 Hours
		PART A  Answer all questions, each carries 5 marks.	Marks
1	,	Write a short note on microsystem packaging.	(5)
2		What is etching? What are the different types?	(5)
3		Briefly explain about the standard clean room for micromachining.	(5)
4		Explain about micro milling.	(5)
5		Explain the concept of pressure sensor with neat diagram.	(5)
6		Discuss about microvalves.	(5)
7		Explain the application of MEMS in defence industry.	(5)
8		What is scaling? What is the need for scaling?	(5)
		PART B  Answer any three full questions, each carries 10 marks.	
9	a)	Explain CZ method for producing pure silica crystal with neat diagram.	(10)
10	a)	What is photolithography? What are the steps involved in photolithograph	ny? (10)
		explain.	44.00
11,	a)	Explain the working of Laser Beam Micromachining. Write its applications.	(10)
12		Write a short note about	(10)
		a) Micro milling	
		b) Micro drilling	
13	a)	Explain electrochemical machining with neat sketch.	(10)
		PART C	
• •		Answer any two full questions, each carries 15 marks.	(10)
14	a)	Explain microgrippers and micromotors.  Illustrate acoustic wave sensor with proper explanation.	(5)
	b)	mustrate acoustic wave sensor with proper explanation.	( )

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15 a)	Describe the principle of	(15)
	a) Chemical sensor b) Optical sensor	
16 a)	Explain scaling in	(15)
Types for a	a) Geometry	
	b) Electrostatic force	
17 a)	List and explain various applications of MEMS.	(15)